

REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 2800
Docket No. 1514.1010

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Woo Young SO et al.

Serial No. 10/068,004

Group Art Unit: 2826

Confirmation No. 6442

Filed: February 8, 2002

Examiner: Ahmed N. Sefer

For: THIN FILM TRANSISTOR AND MANUFACTURING METHOD THEREOF, AND ACTIVE
MATRIX DISPLAY DEVICE AND MANUFACTURING METHOD THEREOF

AMENDMENT AFTER FINAL REJECTION

Mail Stop AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Final Office Action mailed June 8, 2007, and having a period for response set to expire on September 8, 2007, which replaced the Final Office Action mailed May 18, 2007, and restarted the period for response.

The following amendments and remarks are respectfully submitted. Entry of this Amendment After Final Rejection and reconsideration of the claims is respectfully requested.

Amendments to the claims are reflected in the listing of the claims that begins on page 2 of this paper.

Remarks begin on page 6 of this paper.